

Compositional dependencies of Raman spectra of Ge-As-Se chalcogenide glasses

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Chalcogenide glasses are known as perspective materials of optoelectronics with a high optical transparency in the infrared region of telecommunication windows 3-5 and 8-12 μm . In this work, influence of composition on structural transitions and optical properties of chalcogenide glasses was studied by Raman technique. Obtained Raman spectra chalcogenide system $\text{Ge}_{4.5}\text{As}_{14.5}\text{Se}_{81}$, $\text{Ge}_{13.5}\text{As}_{23.5}\text{Se}_{63}$ and $\text{Ge}_{18}\text{As}_{28}\text{Se}_{54}$, $\text{Ge}_{27}\text{As}_{37}\text{Se}_{36}$, $\text{Ge}_{30}\text{As}_{40}\text{Se}_{30}$ were analyzed using CoRa software. The Ge-Se vibrations in $[\text{GeSe}_4]$ tetrahedrons occurred at 193 cm^{-1} . The As-Se vibration band generally occurs at around 230 cm^{-1} . In the higher frequency region, there occurred a weak band at 250 cm^{-1} with a broad shoulder at 300 cm^{-1} , assigned to Se-Se vibrations in Se-chains and asymmetric stretches in $[\text{GeSe}_4]$, respectively. The existence of Ge-Ge bonds is indicated by the shoulder occurring in the region $170\text{--}180\text{ cm}^{-1}$ at the lower frequency side of the Ge-Se band, assigned to Ge-Ge vibrations in $[\text{Se}_3\text{Ge-GeSe}_3]$ structural units. The band at 100 cm^{-1} is assigned to As-As vibrations, and its shoulder at 130 cm^{-1} to Ge-As vibrations. As the content of germanium increases, the chance for tetrahedrons $[\text{GeSe}_4/2]$ meeting each other increases, which is indicated by the occurrence of edge-shared $[\text{GeSe}_4/2]$ band at 214 cm^{-1} . Thus, the structure of the glasses is described as a mixture of the $\text{AsX}_{3/2}$ and $\text{GeX}_{4/2}$, connected either directly or through chalcogen chains and with presence of non-stoichiometric structural units.

Topics

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